

RhicEbis Design and Performance*

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***Project funded by US Department of Energy
and the National Aeronautics and Space Administration**

Two simultaneous users of RhicEbis ions

EBIS & RFQ & Heavy Ion Linac



Au, Fe, He, U, etc.

In addition the EBIS must be able to diagnose operating performance and prepare for new beams, parasitically.

These considerations lead to a choice of electrostatic beam transport and switching in LEBT and a pulsed HV EBIS platform



Relativistic Heavy Ion Collider



NASA Space Radiation Lab

EBIS based preinjector vs Tandem

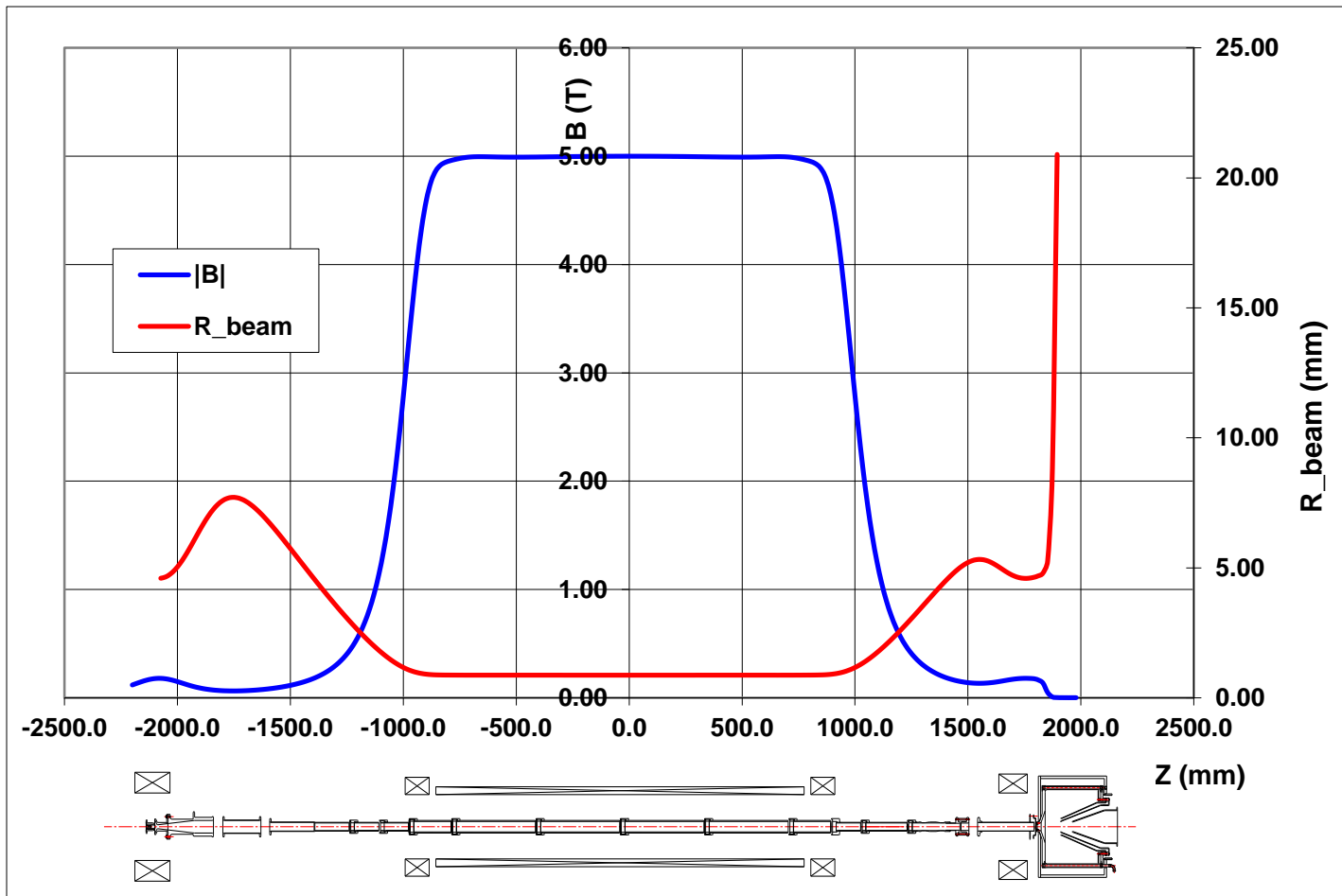
- Increased flexibility to handle the simultaneous needs of RHIC and NASA (fast switching between species)
- Capability to provide ions not presently available, such as noble gas ions (for NASA), uranium (RHIC).
- Simpler technology, robust, more modern
- Elimination of two stripping stages and an 860 m long transport line, leading to improved performance (stability, easier tuning).

- High current electron beam ($\sim 10\text{A}$), current density $\sim 600\text{A/cm}^2$
- The goal is to produce high particle currents in intense charge pulses, which are well matched to the acceleration scheme.
- For an EBIS, the charge state is moderate (e.g. Au^{32+}), but the ion currents are high ($\sim 10\text{mA}$) for total extracted charge $> 100\text{nC}$ and short pulses ~ 10 to 40 microseconds.
- In order to maintain high vacuum in the face of electron beam losses and potential high voltage discharges, a warm, baked vacuum system design was used.
- Pumping includes Cryopumps, turbo pumps, sublimation pumps as well as passive and electrically heated NEG pumps. The pressure achieved currently is $2\text{E}-10$ at the gun and $7\text{e}-11$ in the trap.

Some key features of Rhic EBIS

- A **novel electron gun** based on a design from Novosibirsk, which uses a convex cathode
 - produces a low rotational electron beam well suited for the accelerations and decelerations common in the EBIS transport system
- A **warm bore**, unshielded superconducting solenoid for the main trap region
- **Vacuum separation** of the trap region from the electron gun and electron collector regions
- **Large bore** (32mm) drift tubes have been used (pumping, reduced alignment precision, fast extraction, reduced RF coupling)
- The use of auxiliary (warm) solenoids & many transverse magnet coils for **steering corrections** on the electron beam
- The **electron beam is pulsed** to reduce the average power on the electron collector
- **Versatile controls** and hardware allow one easily manipulate the time dependent potential distribution to accommodate various injection and extraction techniques.

RHIC EBIS operates with the electron gun cathode immersed in the magnetic field of a launching coil. The electron beam is then compressed by the main magnetic field.



External ion injection modes:

Fast Injection: Ions are injected into the electron beam in an ion beam pulse typically ranging from a few μs to a few hundred μs . Raising a potential barrier traps the ions axially while terminating further injection. Retarding the incoming beam can greatly increase the linear charge density, lowering the required injector current. The efficiencies can be very high, typically above 50%, and there is a well defined beginning of confinement period.

Slow injection: (accumulation mode) allows trap filling with much lower current beams. The injected ion energy is adjusted so that ions pass over a potential barrier on the way into the trap, but if they are further ionized during a round trip transit and if ionized during a round trip, they will be trapped. In general, this type of injection is much less efficient with trapping rates typically a few percent or less.

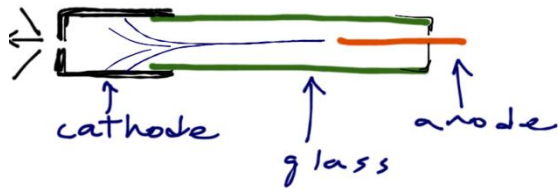
This mode can be useful when efficiency is not important or when the incoming beam is very low intensity and accumulation is essential. High electron beam current densities help improve the efficiency.

RhicEbis usually operates in the accumulation mode which places less demand on the external injection sources and beam transport.

External 1+ ion production
to feed the EBIS trap

Cu source

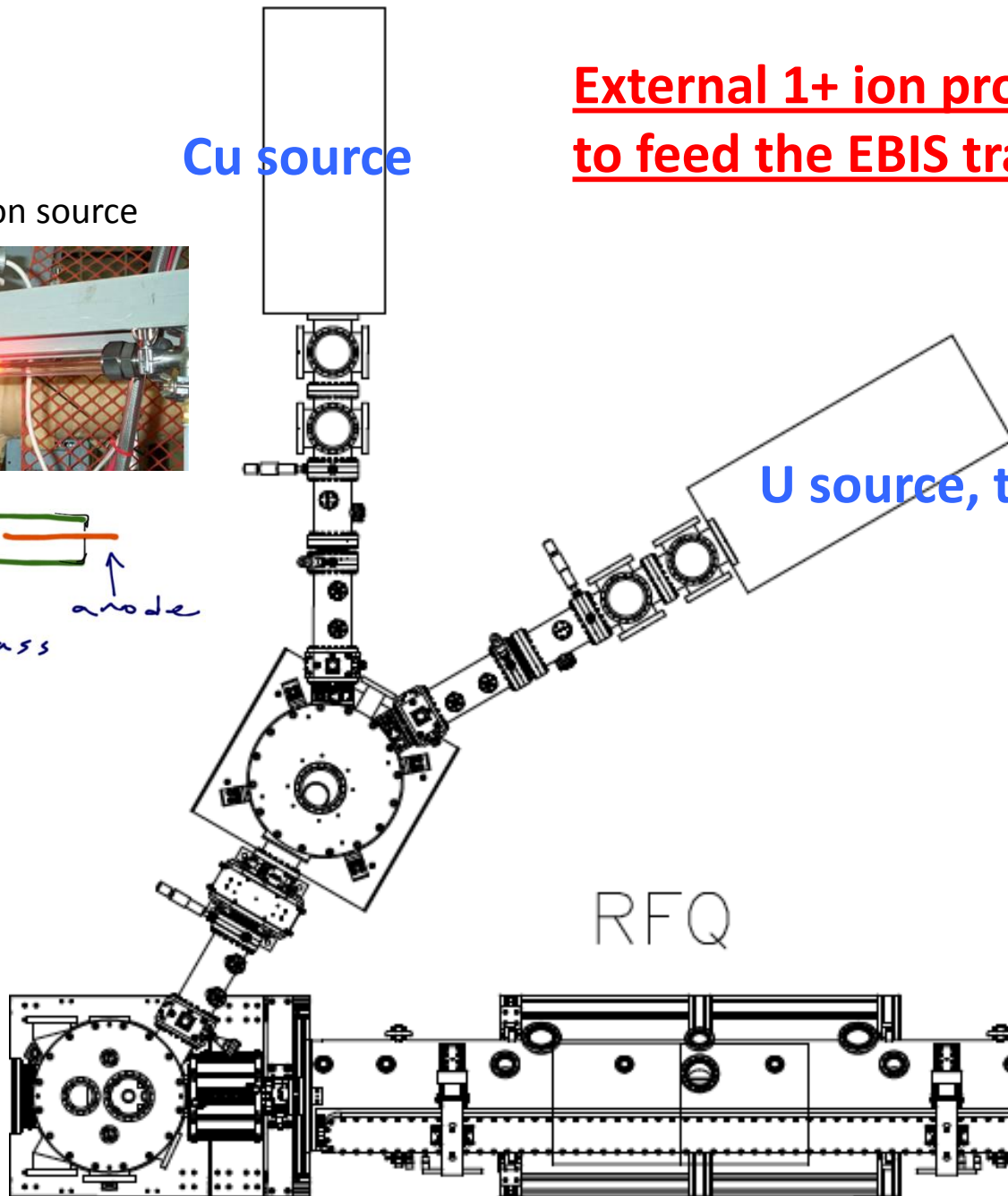
Hollow cathode ion source



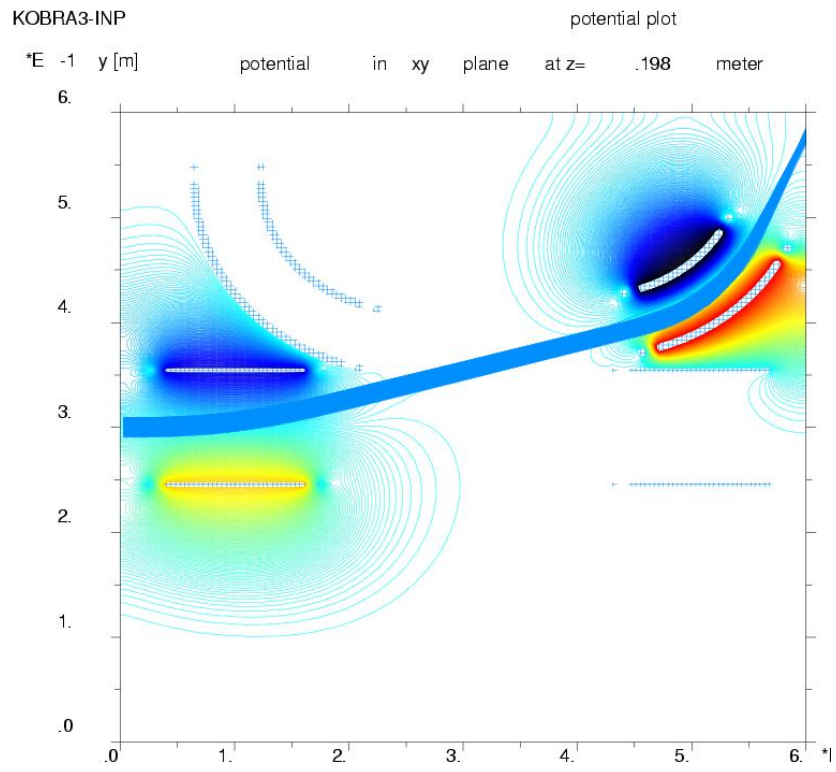
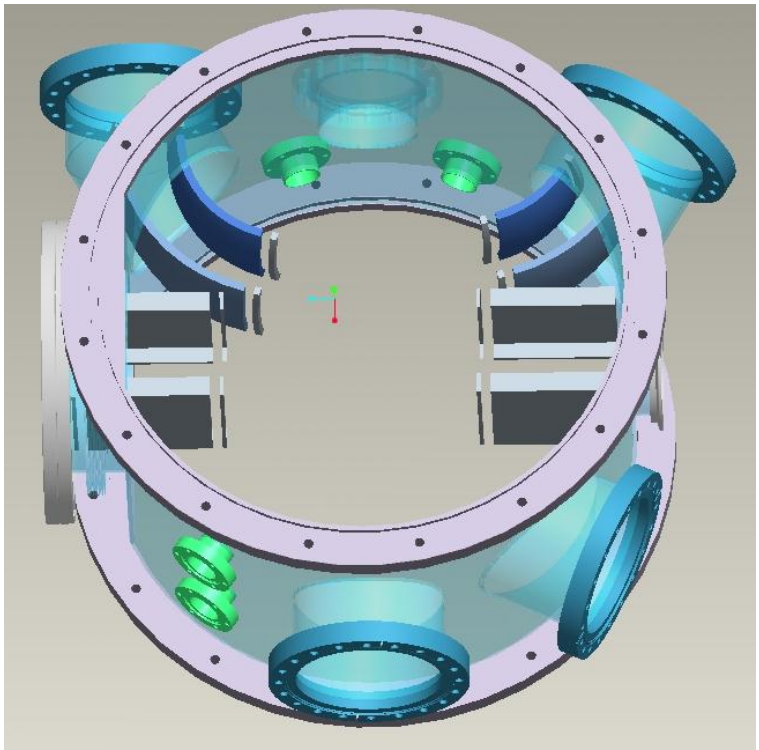
U source, then Au

EBIS is a "charge breeder" of the injected 1+ ions

1+ Ions
into EBIS

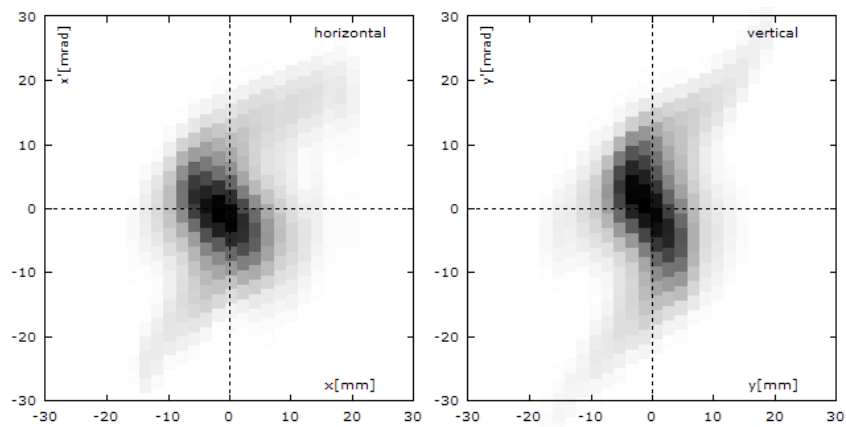


LEBT Switchyard and Diagnostic Chamber



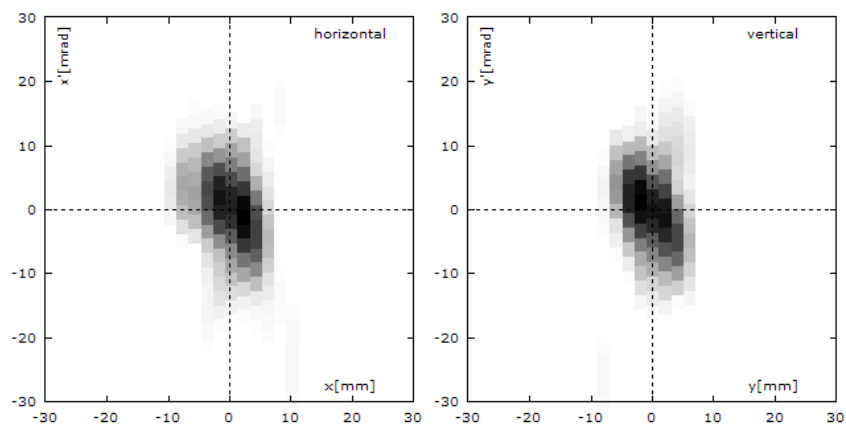
Left: Multi-port LEBS chamber with spherical & flat bending elements for ion injection into EBIS

Right: Simulated 15keV beam trajectory for injection into the EBIS



Emittance at the exit of the LEBT chamber, Cu^{1+} , 11 keV, 10 μA .

Aberrations observed when the beam fills the quadrupole aperture.



Emittance at the exit of the LEBT chamber when the beam is collimated between the ion source and the first quadrupole.

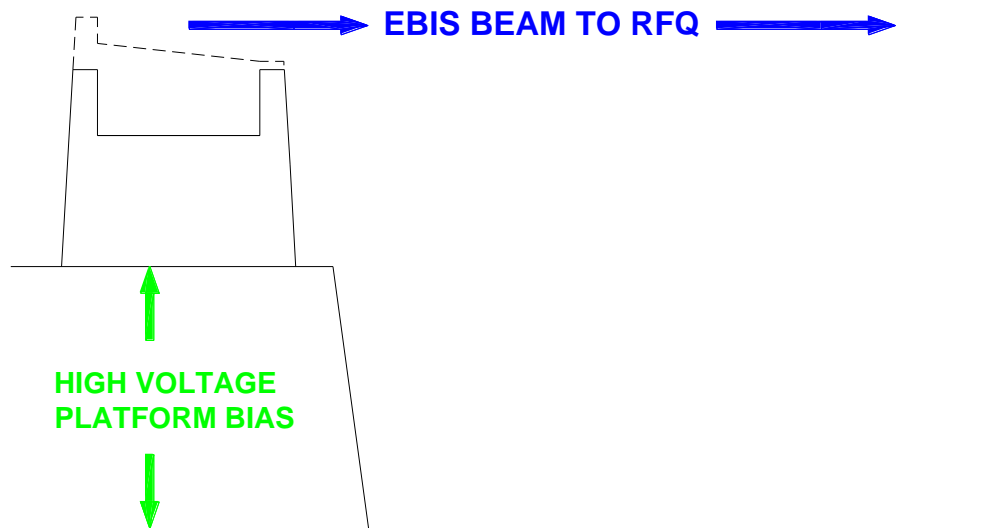
Output emittances with collimation are $\leq 0.02 \pi$ mm mrad, norm., rms.

Ion Elevators: Pulsed High Voltage Platforms

ION TRAPPING

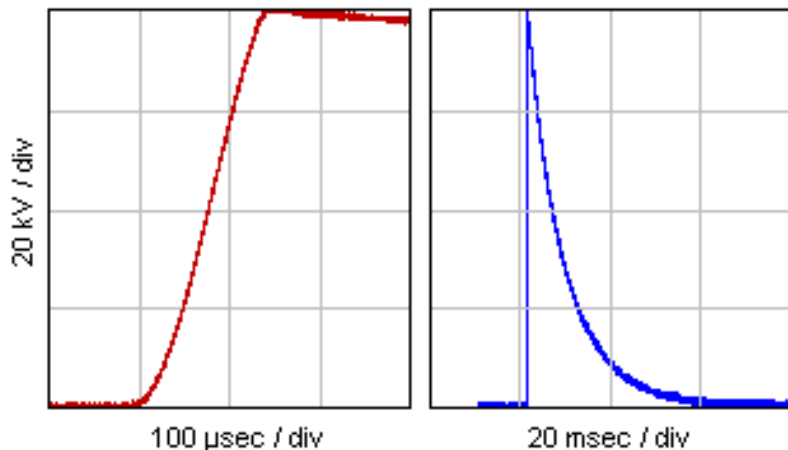


During injection and confinement the RHIC EBIS operates at ground potential.



Just before ion extraction the EBIS Platform Voltage is applied such that the ions are extracted through 100kV (nominal) to attain the $\sim 17\text{keV/amu}$ needed for acceleration by the RFQ

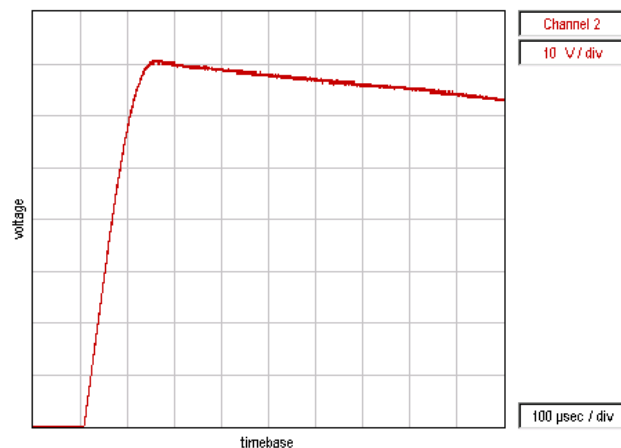
(Platform pulsing is also useful for injection and TOF energy adjustments)



80kV pulsing of Test EBIS Platform:

–100 μ s/div shows rise time and Flat Top (Far Left)

–20ms/div shows recovery to ground between EBIS cycles. (maximum EBIS Repetition frequency is 5Hz)



RHIC EBIS Platform pulsed to 100kV
(baseline is offset 30V below screen lower limit)

Red Trace: Platform potential (1V=1kV)

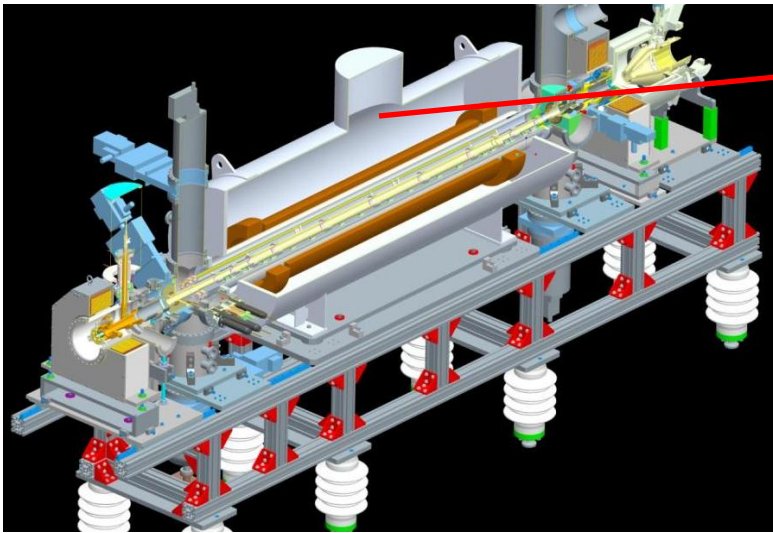
Horizontal scale is 100 μ s/div

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EBIS Superconducting Solenoid

- Length of the SCS coil: 190 cm
- Magnet field: 5 T
- Warm bore inner diameter: 204 mm (8")

Solenoid is twice the length of that used for R&D prototype EBIS



RHIC EBIS design parameters

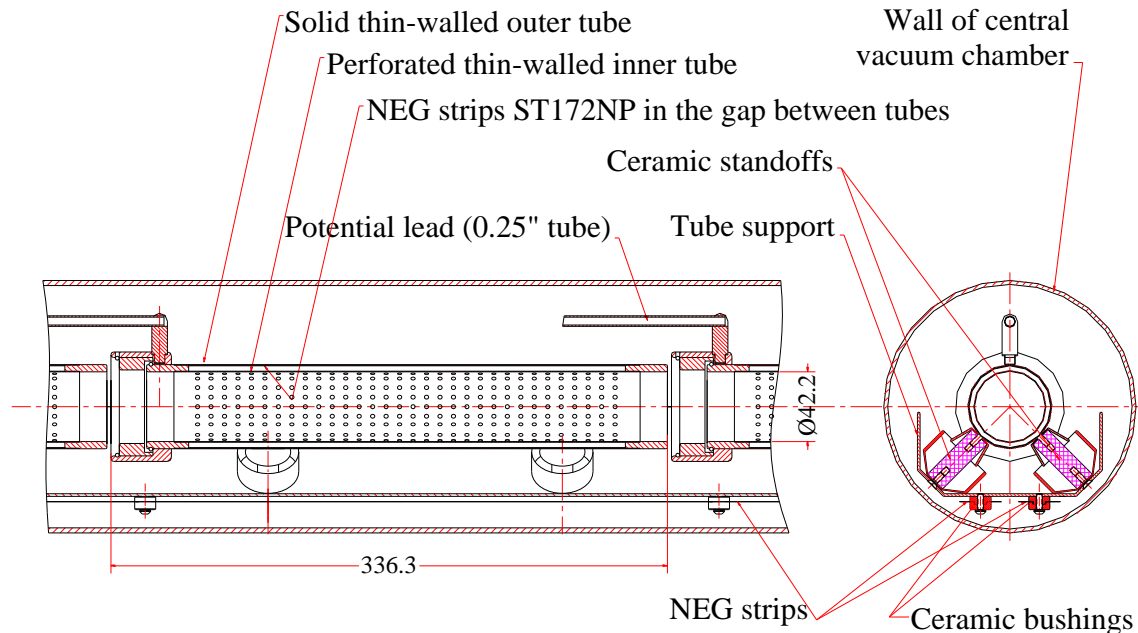
Parameter		RHIC EBIS
Max. electron current	$I_{el} =$	10 A
Electron energy	$E_{el} =$	20 keV
Electron density in trap	$j_{el} =$	575 A/cm ²
Length of ion trap	$l_{trap} =$	1.5 m
Ion trap capacity	$Q_{el} =$	1.1×10^{12}
Ion yield (charges)	$Q_{ion} =$	5.5×10^{11} (10 A)
Yield of ions Au ³²⁺	$N_{Au^{32+}} =$	3.4×10^9

RHIC EBIS unshielded superconducting solenoid manufactured by ACCEL:

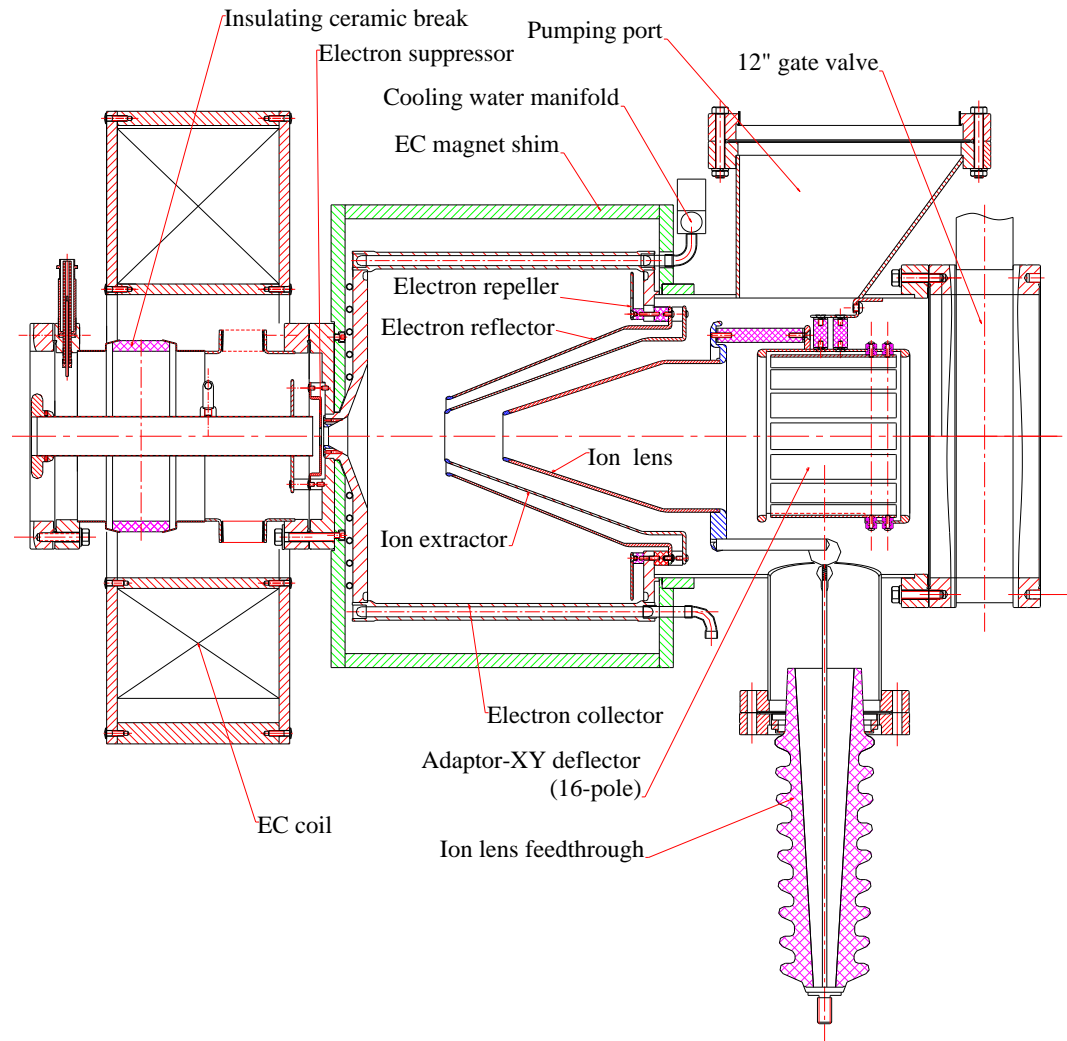
Maximum magnet field	5.0 T
“Warm” ID	204 mm
Length of solenoid	1900 mm
He refilling period	30 days

Rhic EBIS Upgraded pumping capabilities compared with Test EBIS :

- Larger inner diameter of drift tubes (42 mm instead of 31 mm) to reduce ion losses and further reduce electron beam – wall coupling (which may be important for higher electron current)
- Added actively heated NEG strips in the central chamber and passive NEG on inner surface of drift tubes to improve vacuum conditions in the ionization region

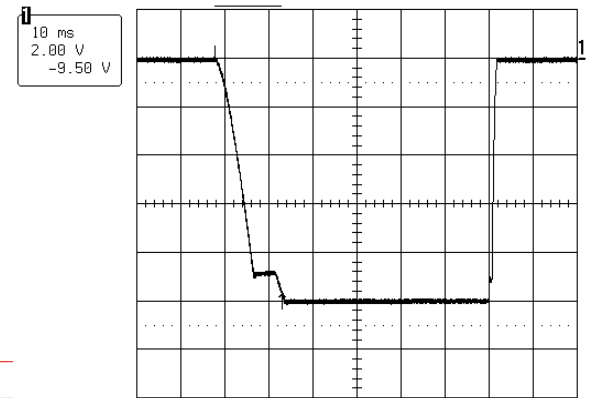
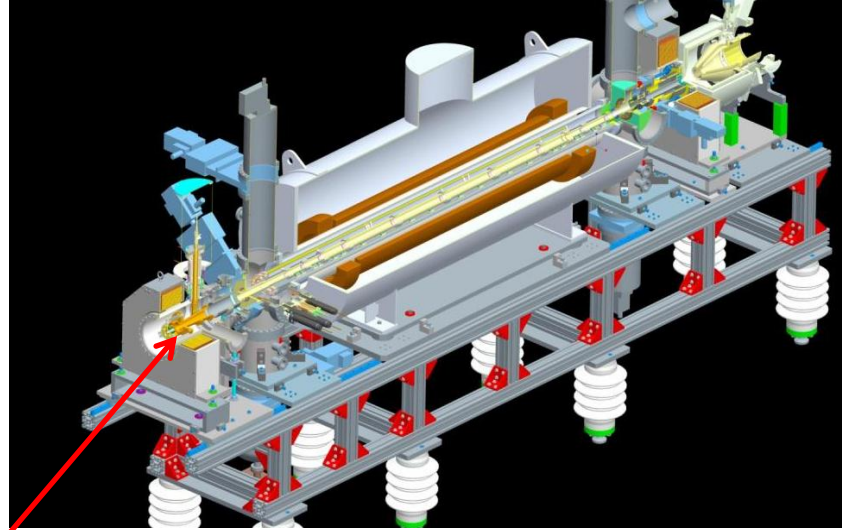


- Improved ion optics for extraction and injection with larger apertures to accomodate larger angles

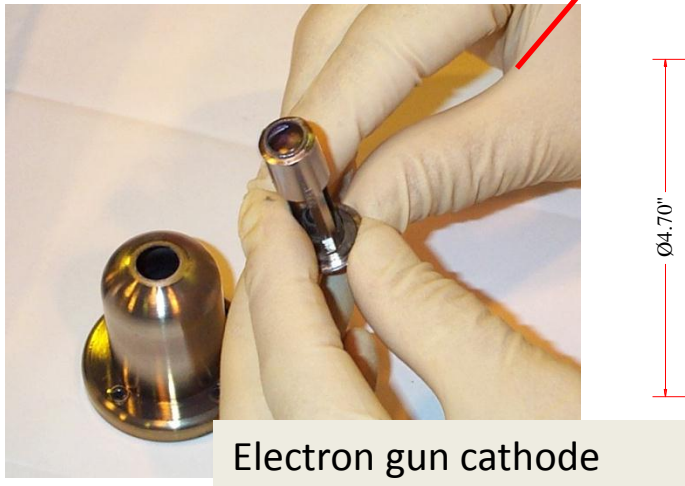


The EBIS 10A electron gun

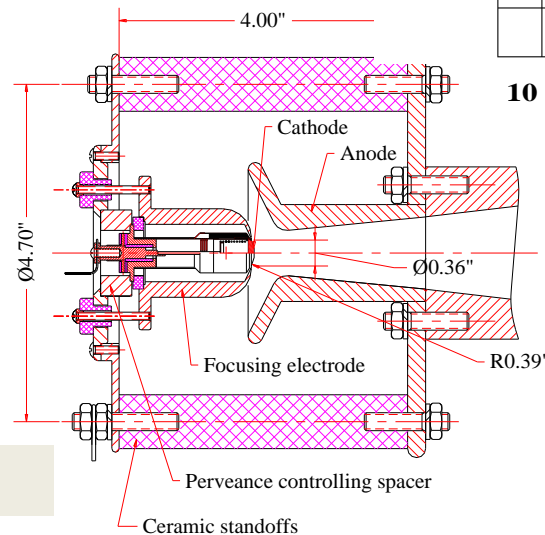
- This was a key development. Previous EBIS operation was typically at 0.5A or less
- Electron beams up to 10A, 100kW have been propagated with very low loss, using IrCe cathodes from BINP, Novosibirsk.



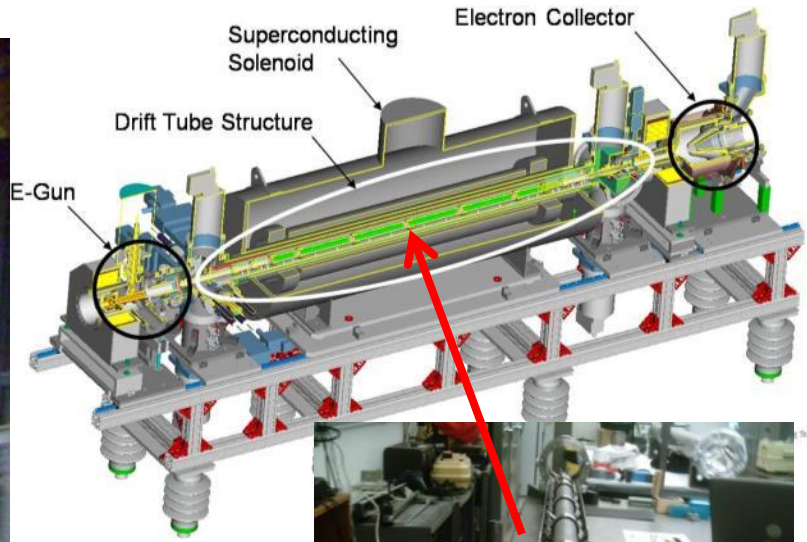
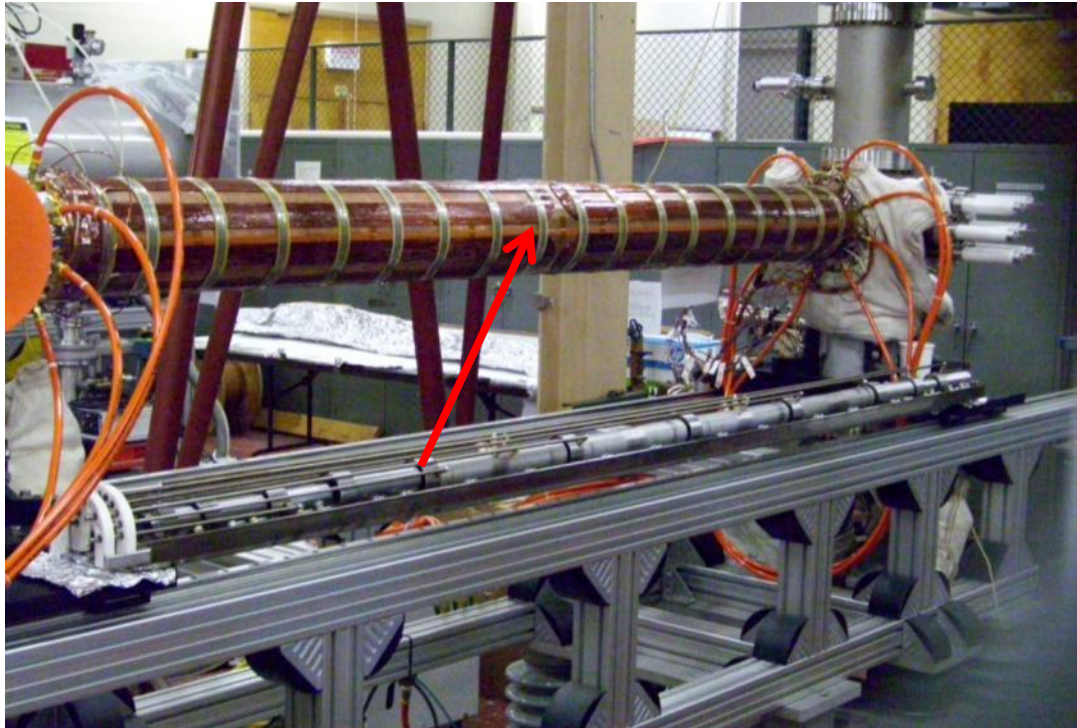
**10 A, 50 ms Electron Beam Pulse
(R&D EBIS)**



Electron gun cathode



Drift tube structure



EBIS Drift tubes

Large-bore drift tubes sit inside the central vacuum tube.

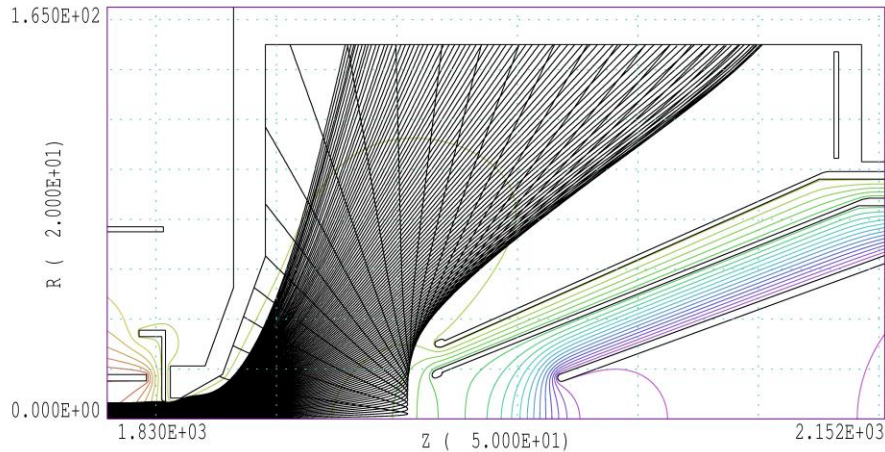
Heaters on the outside of the vacuum pipe allow baking to 450 C.

Outside the water cooled jacket, there are transverse steering coils.

EBIS electron collector

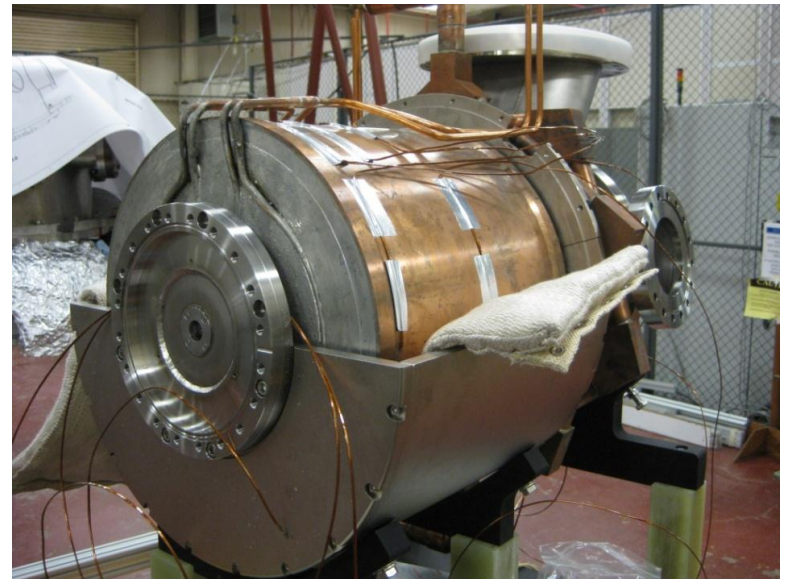
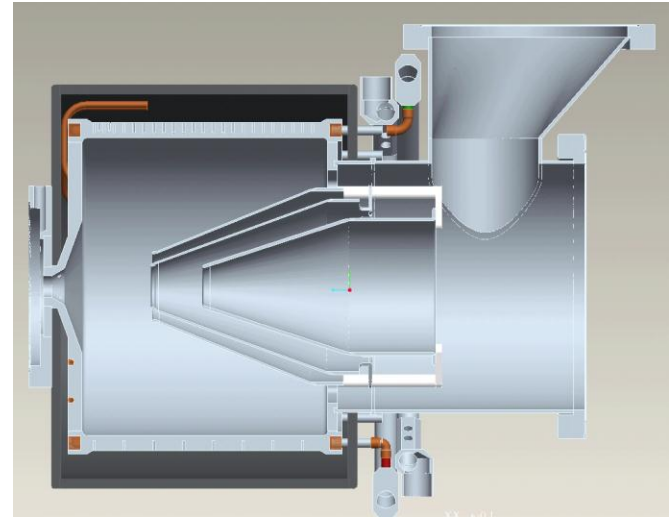
Another key development.

Electron collector capable of dissipating electron beam up to 20 A (300 kW peak power) with length 50 ms and frequency 5 Hz

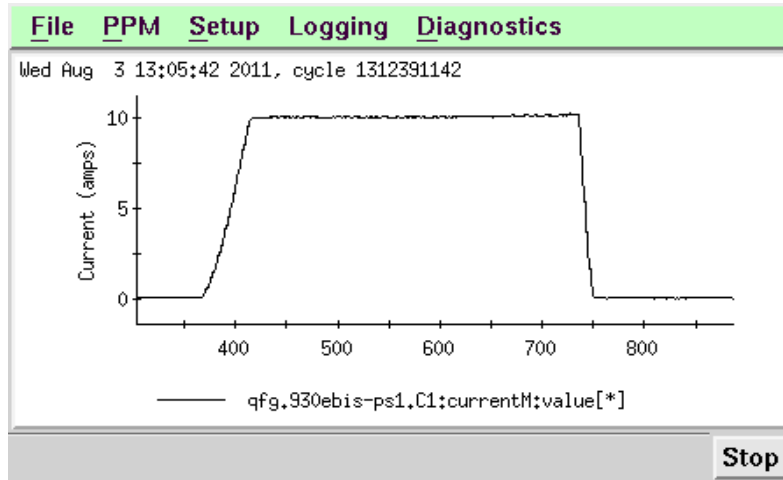


Trajectory simulations in RHIC EBIS electron collector. $I_{el}=20.6$ A, $E_{el}=15$ keV

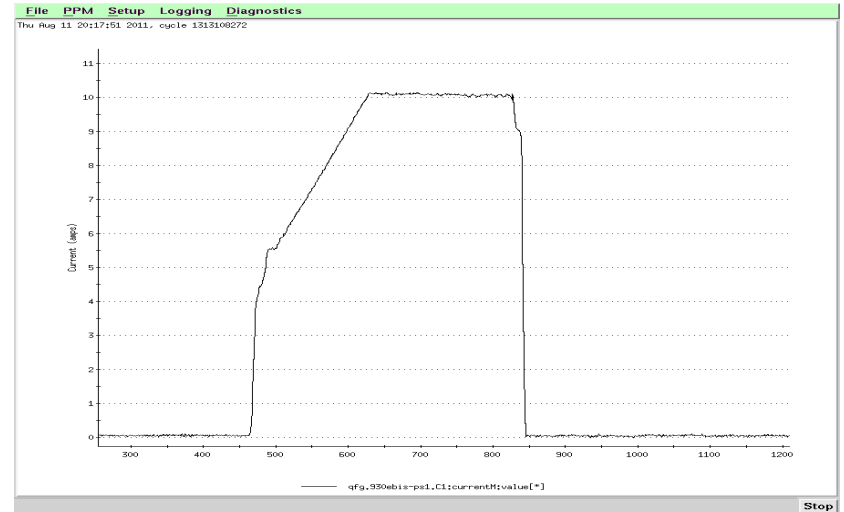
BeCu collector is installed on the RHIC EBIS



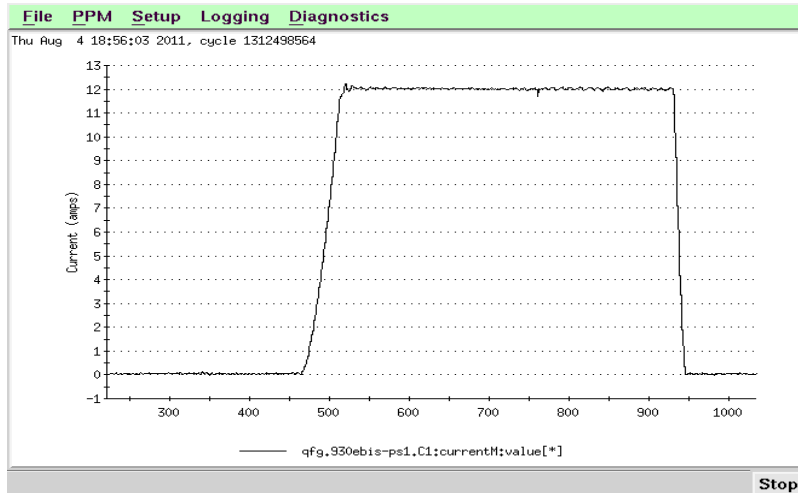
EBIS high electron beam current traces



First 10.1A 32ms e-beam in RhicEBIS



10A, 35ms used for Au ion production (82nC)

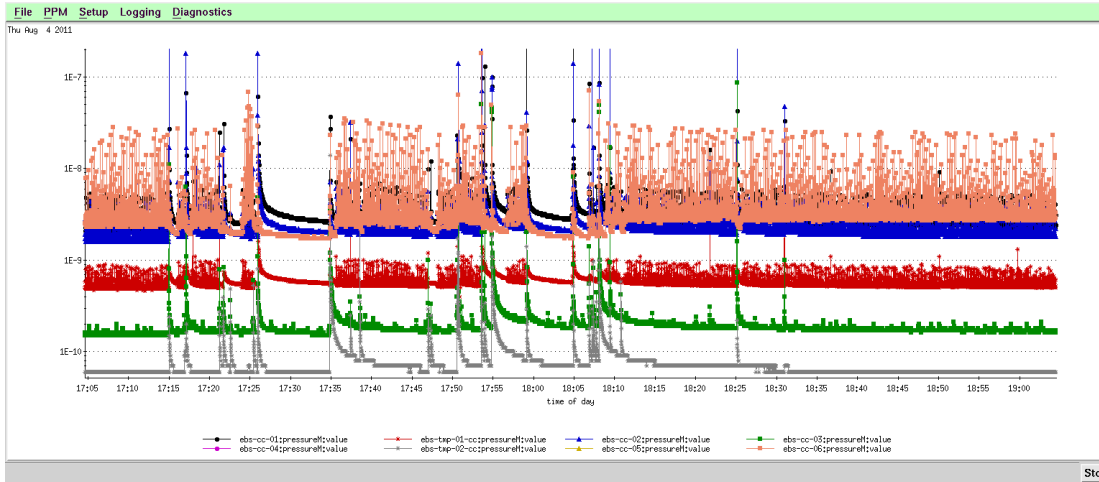


12A 40ms ebeam

Initially, propagation of high electron beam current is obtained using rather simple drift tube electrode voltage and electron current distributions.

Later, when ion trapping is added, more complex distributions are used to accommodate ion injection, ion trapping, and ion extraction, while maintaining a very low loss electron beam propagation.

EBIS Pressures with high electron beam current



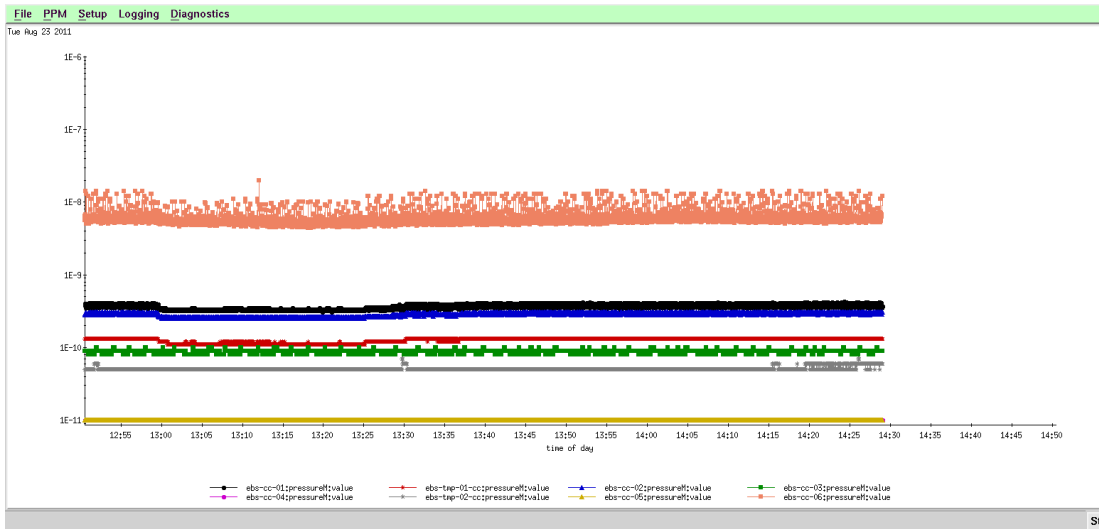
Pressures log for a 12A, 40ms beam

$P_{\text{gun}} = 5 \text{ E-}10$

$P_{\text{trap}} = 2 \text{ E-}9$

$P_{\text{col}} = 3 \text{ E-}9$

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Pressure log for 7.6A e-beam with a 65ms ion confinement

Extracted ions:

70nC Au with inj, 1nC no inj

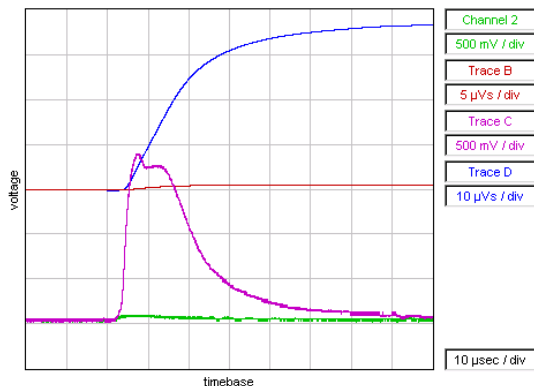
$P_{\text{gun}} = 1.5 \text{ E-}10$

$P_{\text{trap}} = 9 \text{ E-}11$

$P_{\text{col}} = 5 \text{ E-}9$

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Highly charged Au extraction from RhicEBIS after fast injection from the HCIS



Au pulse (all charge states), slightly slowed extraction

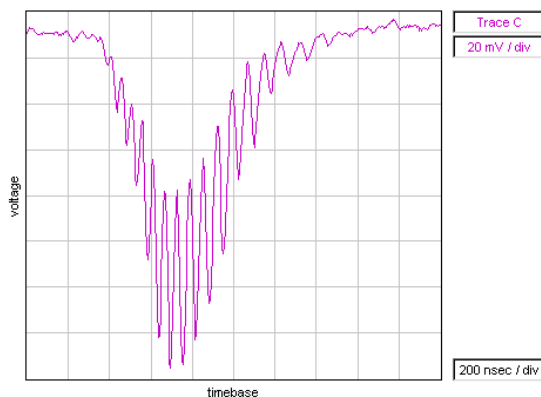
ChC Magenta: (Current with Au+ inj) **3.5mA**, 1 mA/div, 10 μs/div

ChD Blue: (Total extracted charge) **70nC**, 20uVs/div

Ch2 Green: (Current without Au+ inj) **0.2mA**, 1 mA/div, 10 μs/div

ChB Red: (Total extracted charge) **1nC**, 10uVs/div

File name: 110823-08_Au_70nC_7.5Ae_65ms_on_neg_8kV
_platform_fast_Inj_HCIS1_16kV_pulser_at_63_1nC_wo_inj.wfm



Left: Au Time-of-Flight Spectrum
(Reflex mode – channeltron EM)
Max peak is Au32+

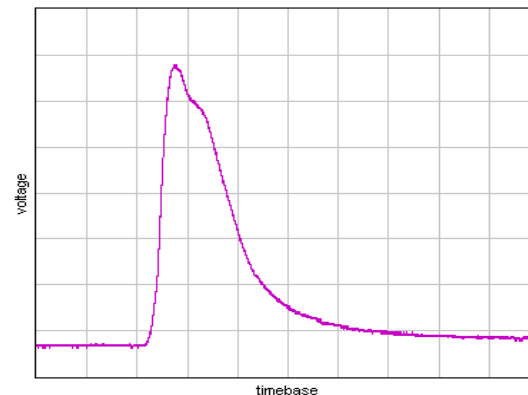
File name: 110823-09_Au_high_res_65ms_conf
_8kV_retardation_7.6A_Au32.wfm

Right: Au pulse (all charge states), faster extraction

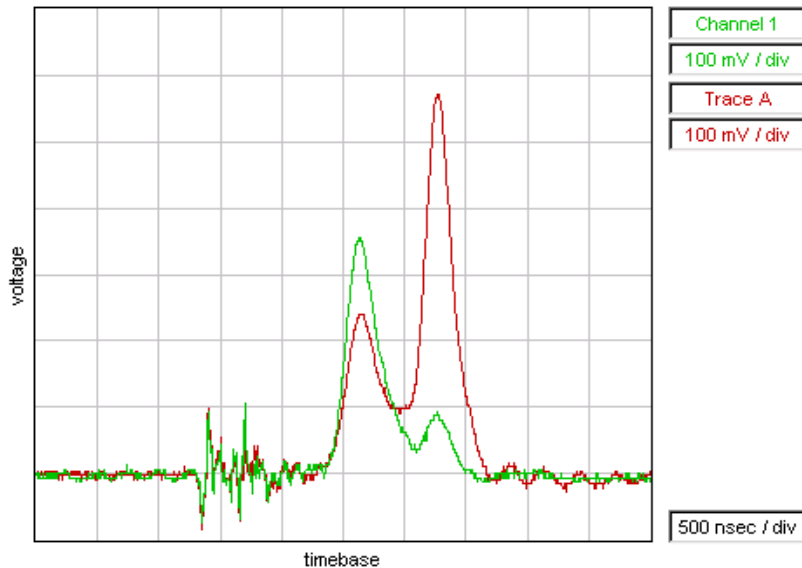
~6 mA peak, at EBIS output

1 mA/div, 10 μs/div

I(e)=7.6A, 65 ms confinement



Rhic EBIS Low resolution TOF after 15 degree bend



Red Trace: With Au+ injection from HCIS

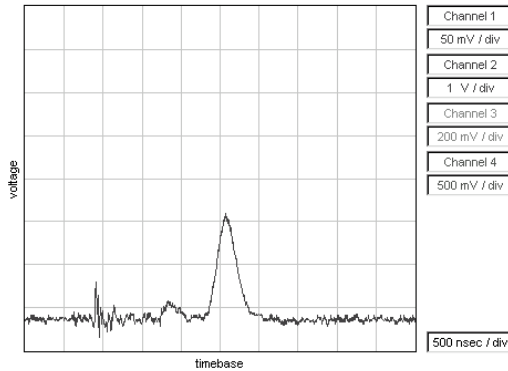
Green Trace: reduced Au+ injection
(Au injection not completely “off”)

High background; unbaked system

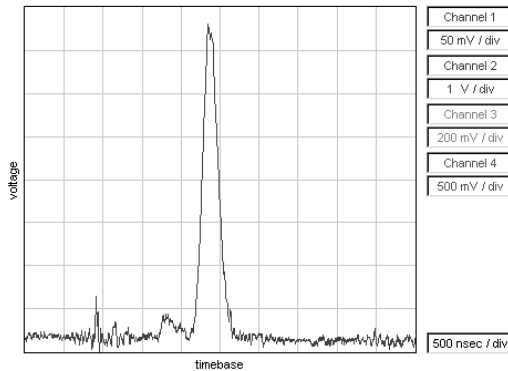
Low resolution TOF spectrum measured on a Faraday Cup shows a gold fraction of extracted charge is approximately 60%.

Electron current $I_{e1}=5.6$ A, confinement time $\tau_{conf}=36$ ms, dominant Gold ion charge state is $\sim 30+$.

Au Time-of-Flight (25ms confinement)
(peaked at Au²⁵⁺)

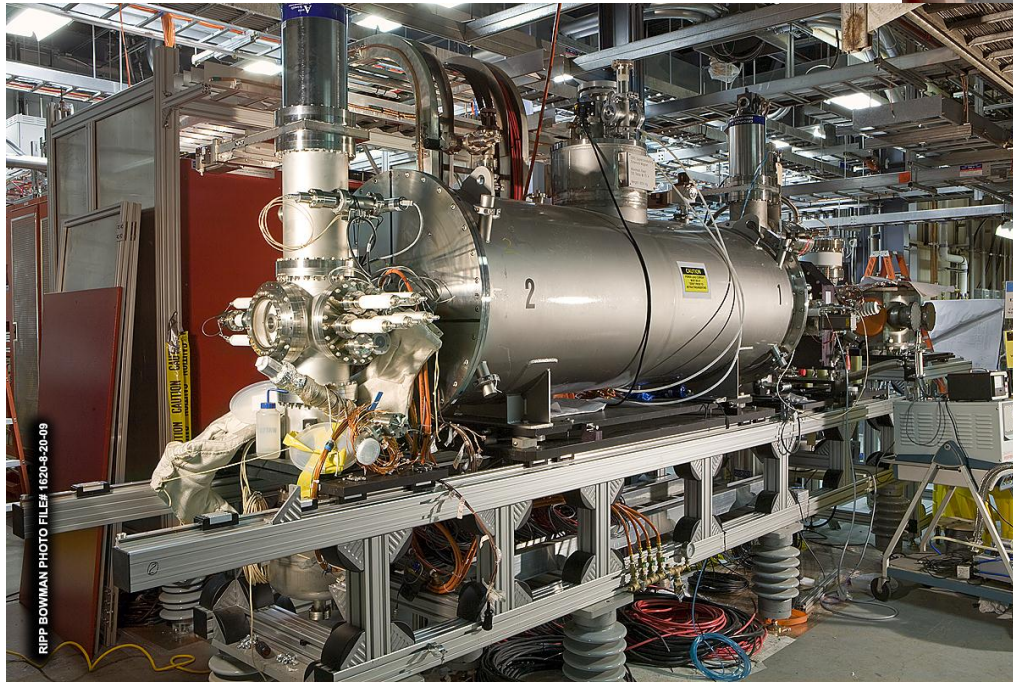
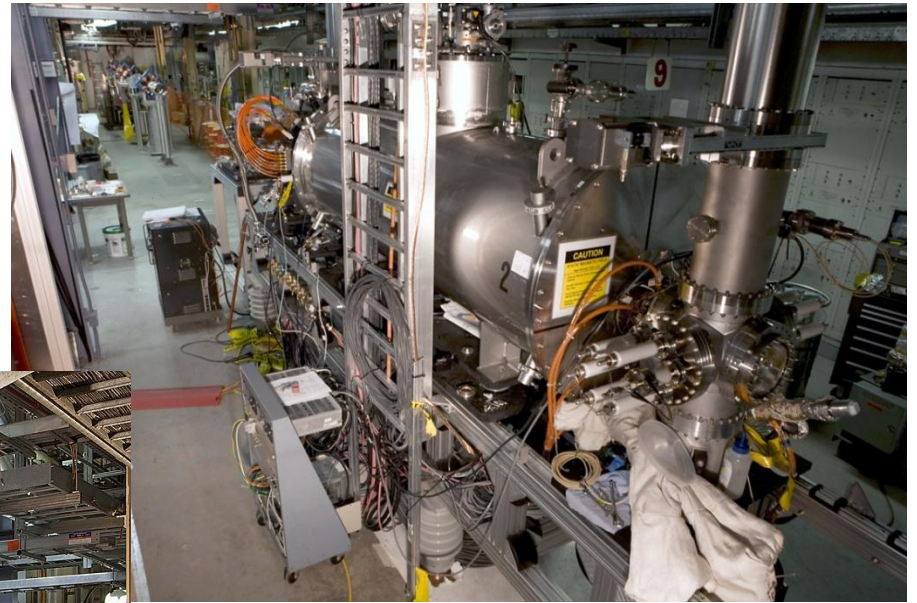


Au Time-of-Flight (65ms confinement)
(peaked at Au³²⁺)



Well baked system and excellent electron beam propagation result in very pure Au spectrum.

EBIS during installation

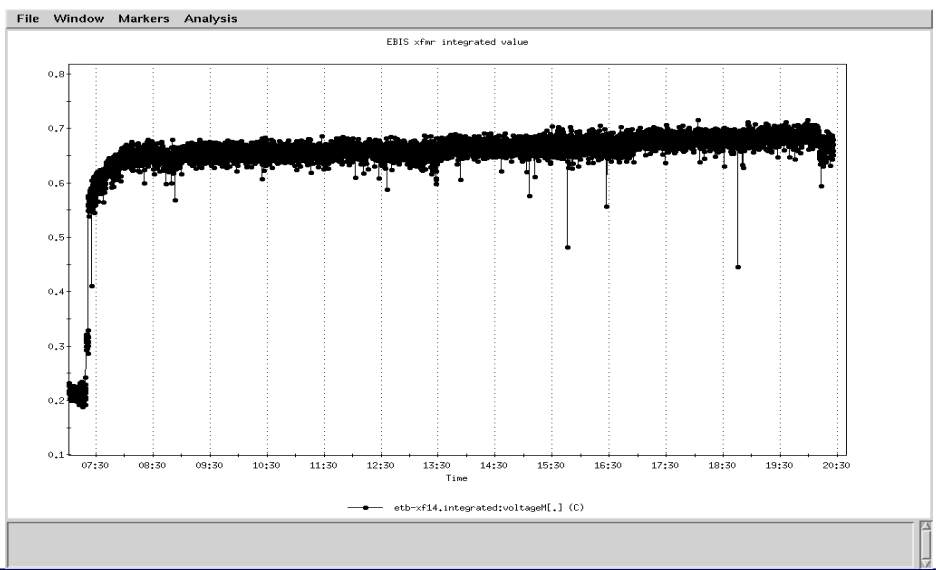


11 Racks of power supplies for EBIS, all pulsing to 100 kV along with the EBIS, during ion extraction.



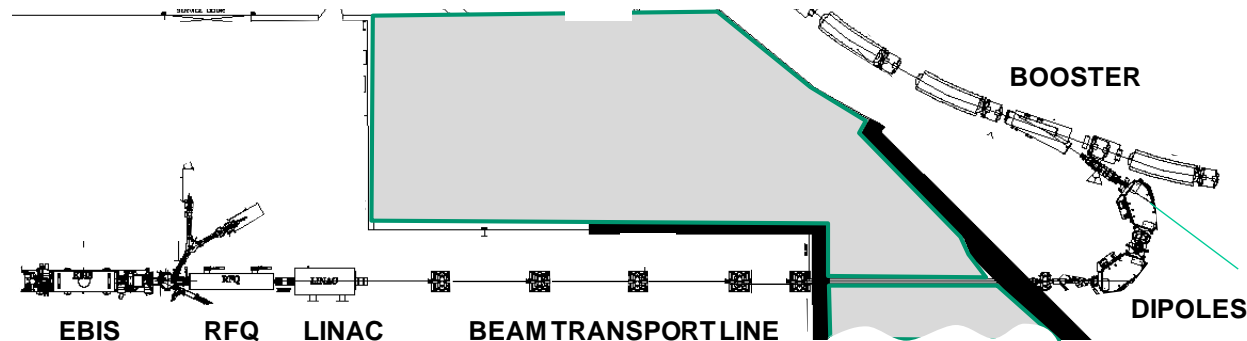
Summary of First Run to NSRL (Mar-Jun 2011)

- EBIS operated ~ 6 days/ week, 12-16 hours/day, from ~ March through June
Delivering beam to NSRL, and working on adding species and increasing intensities
- Ran 38 days for NSRL biology experiments
Delivered Fe 20+, He 2+, Ne5+, Ar10+, and Ti18+ beams
(He, Ne, Ar were new beams for NSRL)
No downtime
Excellent stability (eventually got to where it ran for days without any adjustments)
- All RF systems and transport magnets ran 24/7 for ~ 4 months
- All EBIS source, rf system, and transport magnet settings are very reproducible



Fe20+ to NSRL:
Each point on the plot is the integrated current in one EBIS pulse
13 hours without a missed pulse

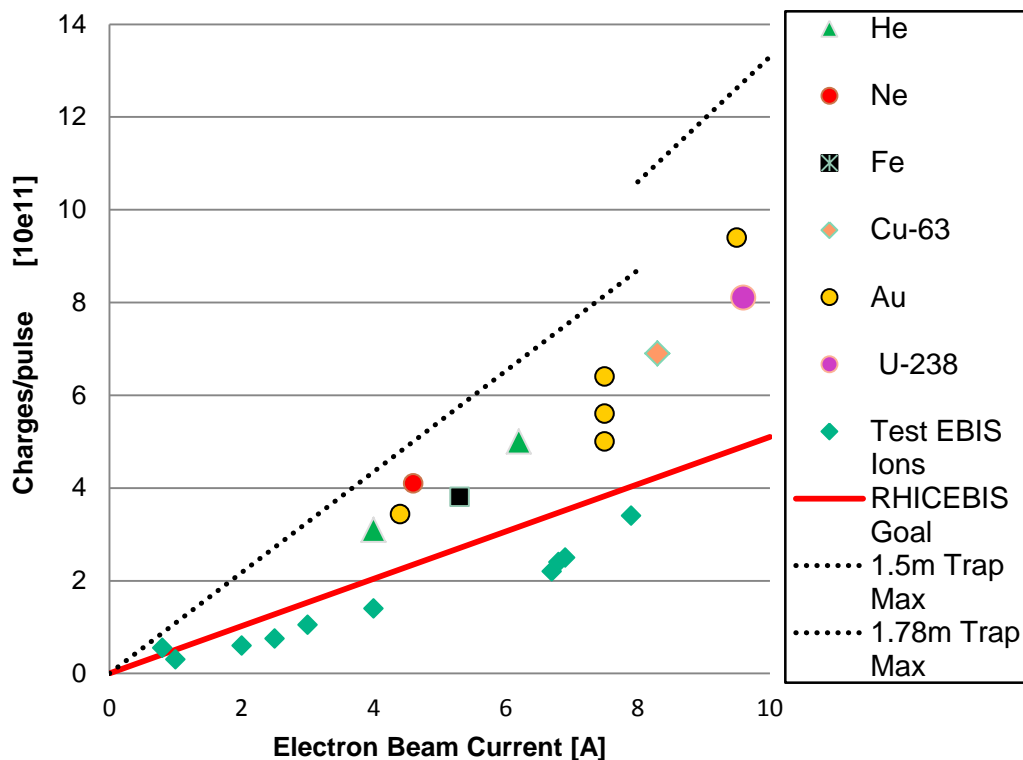
Rapid switching between ion species



- Ion injection into the EBIS trap was tested first with Fe^{1+} and Au^{1+} (two sources)
- EBIS confinement time was switching between 65 ms for Au^{32+} and 130 ms for Fe^{20+}
- Also switching pulse-to-pulse: platform high voltage, power to all RF systems, current to the large dipoles, and all transport line elements.

This rapid switching of species has been a frequent mode of operation during the RHIC run when both Au^{32+} and Cu^{11+} were delivered by EBIS. Switching will also be necessary when beams are delivered to both RHIC and NSRL.

Ion Yields from RhicEBIS (and TestEBIS)

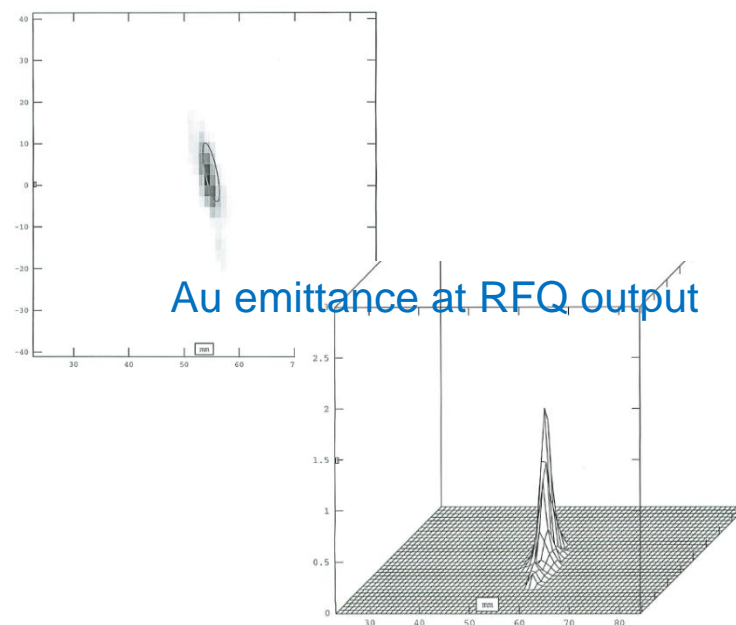


Dotted line is 100% neutralization of the electron beam space charge. Red line is 50% neutralization (design value)

• Ions produced with e- beams up to 10A

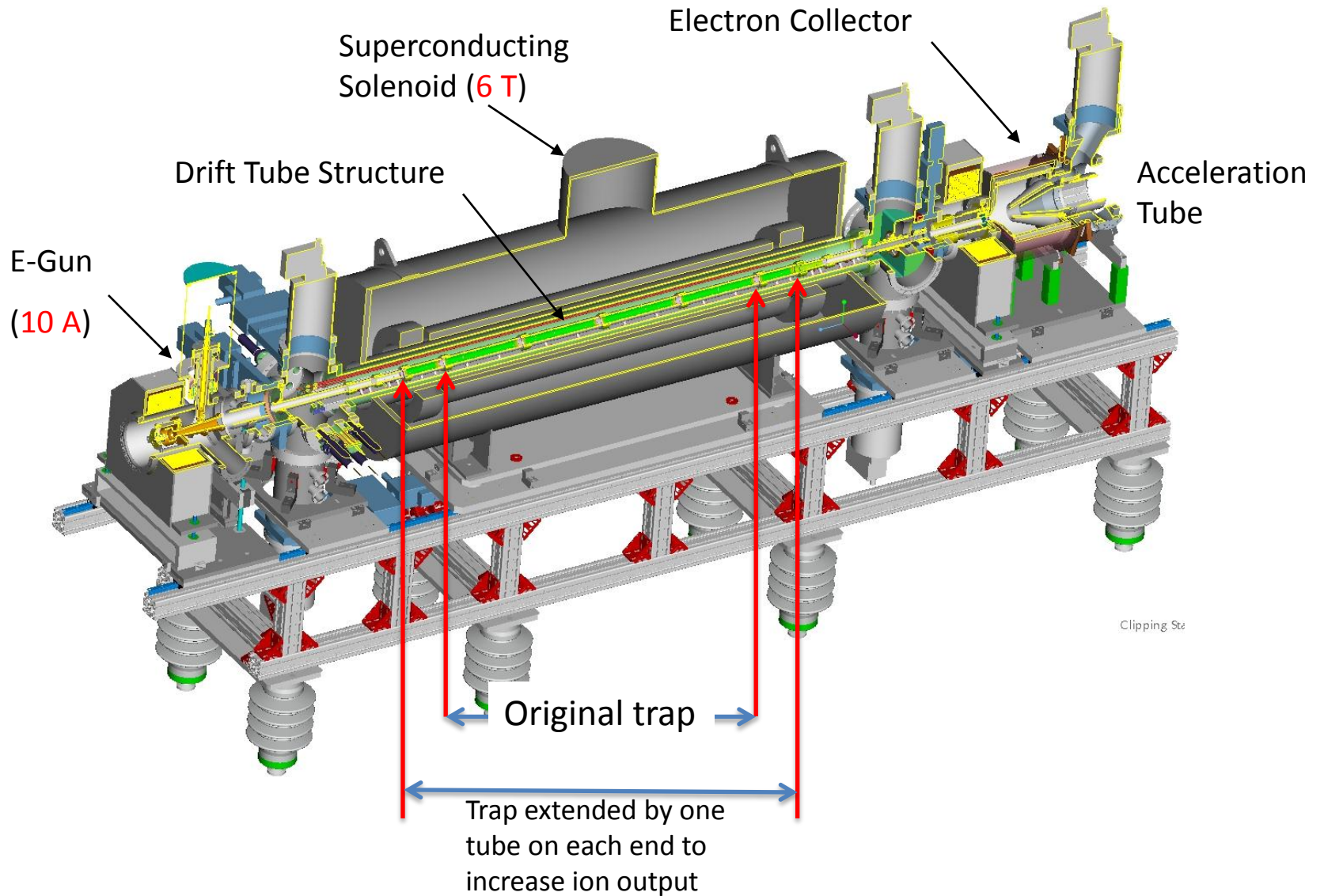
• Ion yield scales properly with I_e

• Cu, Au, U beams using electron beams > 8A benefit from an increased source capacity of ~19% due to a longer axial trap configuration



$$\epsilon(n, \text{rms}) = 0.19 \pi \text{ mm mrad} \quad (2\text{-}3 \text{ mm beam width})$$

Lengthened trap region from 1.5m to ~1.8m. Ion output increased proportionally.



EBIS Ions in Booster (per EBIS extraction)

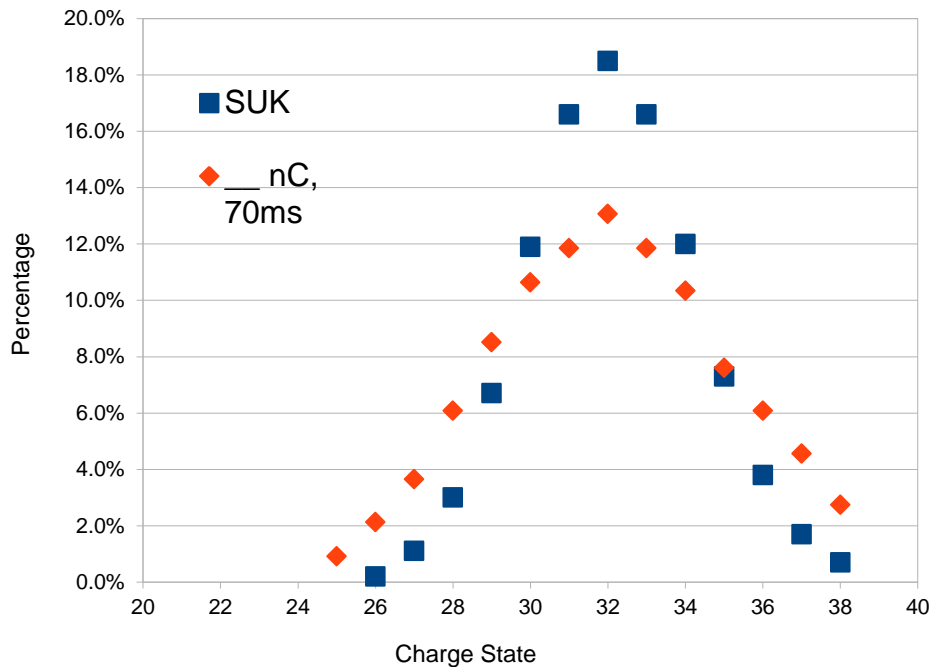
Charge for a single species charge state is measured close to the Booster ring input after the RFQ and Linac and Two dipole bends plus collimation. Measurement is made for best transmission through the rest of the complex rather than for maximizing the charge delivered by EBIS at that location.

EBIS electron Current [A]	Ion	Booster Input (ions)	Booster Input One Ch State (Charges)	EBIS All Ch States (Charges)	Charge Fraction EBIS to Booster
8.3	63Cu11+	6.1e9	6.7e10	6.9e11	9.7%
9.5	Au32+	1.5e9	4.7e10	9.4e11	5.0%
9.6	238U39+	1.1e9	4.2e10	8.1e11	5.2%

Transport to Booster/AGS/Rhic rings with nominal 10A EBIS electron beam operation:

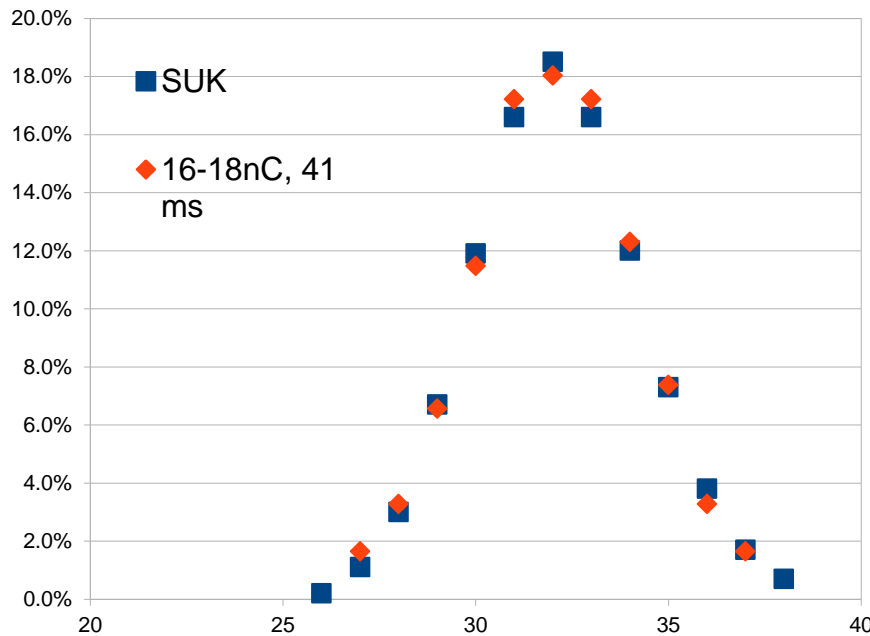
Transmission to Booster input is ~56% of what is expected, and there are additional shortfalls in the the Booster/AGS rings. We believe that the early losses are due to a broadening of the EBIS charge state distribution with high neutralization coupled with a 30% decrease in the RFQ/Linac transmission efficiency due to mismatch and/or emittance growth due to misalignment.

The RHIC injection goals have been met by extending the EBIS trap, doubling the number of EBIS pulses per injection cycle, and performing an extra bunch merge in the AGS ring.



Measured charge state distributions (orange), vs. calculated (blue, R. Becker code), which assumes 100% overlap of ions with electron beam

Normal running at >50% of capacity gives ~13% in desired charge state vs. 18.5% calculated.

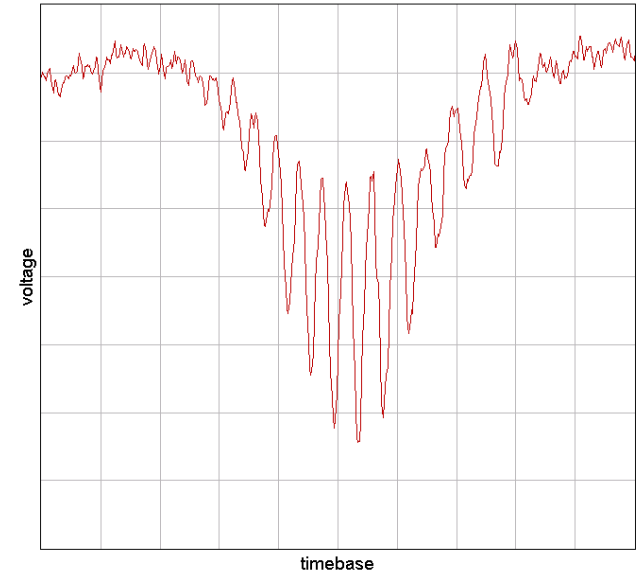
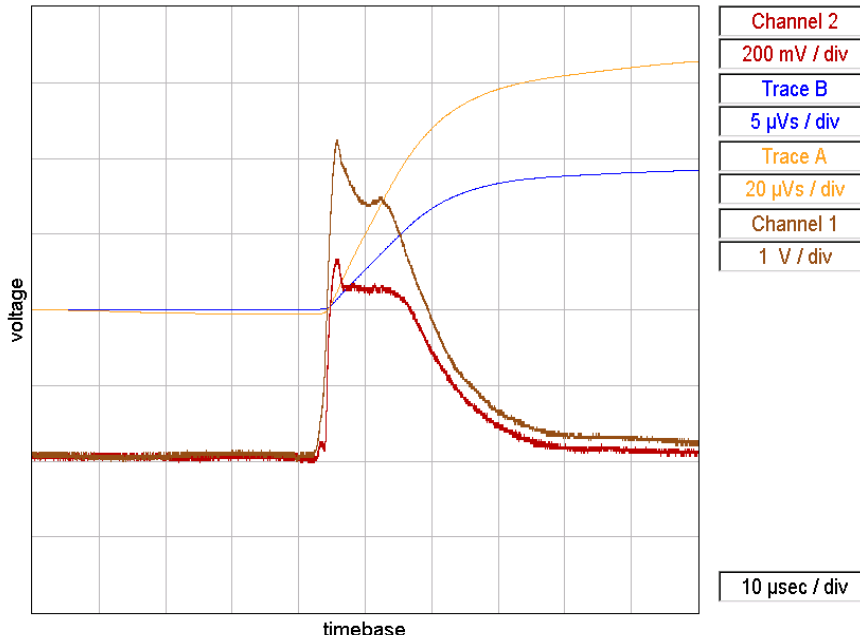


Test at reduced charge - measured distribution matched calculated

13% in 32+ * 75% of capacity = 9.75% vs. design values of 18.5% in 32+ * 50% capacity = 9.25% → Should still be ok

- EBIS operated 7 days/ week, 24 hours/day, from ~ April through June
- First RHIC run with Uranium collisions
- First RHIC run with Au-Cu collisions
- Goals were achieved for RHIC luminosity and bunch intensity - with the addition of bunch merging and higher duty factor EBIS operation.
- No major downtime from the new preinjector
- Excellent stability, eventually getting to where it would run for days without needing any adjustments

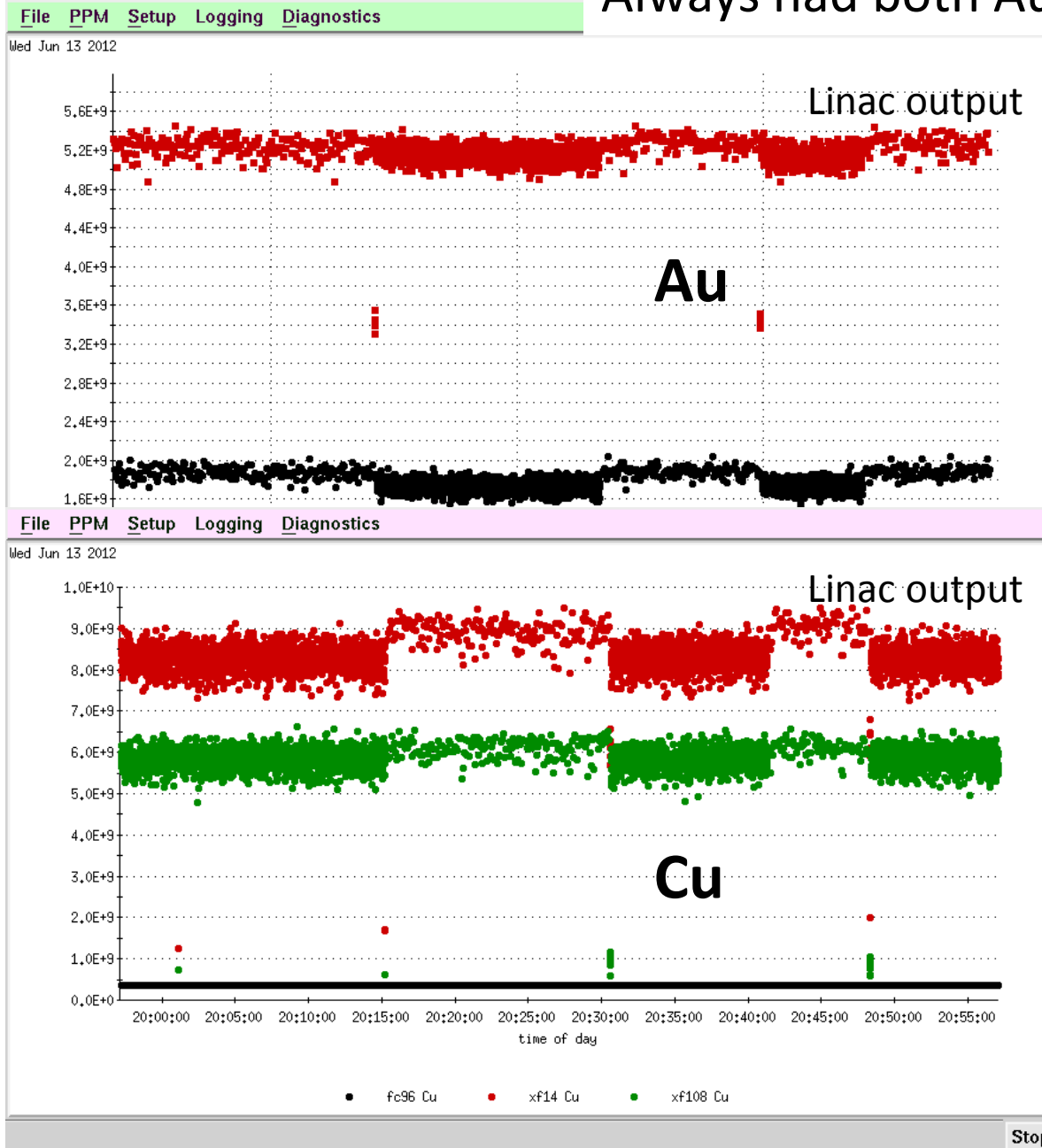
Uranium from EBIS



Uranium (all charge states) at EBIS output and RFQ input (both 2 mA/div)

Uranium time-of-flight charge state distribution; Peak at U 39+ (~13% in the desired charge state)

Always had both Au and Cu running



Each 5 second “supercycle”
8 Au & 1 Cu or
8 Cu & 1 Au or
1 Au & 1 Cu
(during stores)

EBIS confinement time was switching
between 55 ms for Au³²⁺ and 5 ms
for Cu¹¹⁺

Also switching pulse-to-pulse:
platform high voltage, power to all
RF systems, current to the large
dipoles, and all transport line
elements.

Note – single pulse intensity is
higher than the 8-pulse
(difference is even larger when
tuned for single pulse)

Fourteen EBIS beams delivered to date

- He-3 2+ AGS
- He-4 1+, 2+ NSRL
- C 5+ NSRL
- O 6+ NSRL
- Ne 5+ NSRL
- Ar 11+ NSRL
- Ti 18+ NSRL
- Fe 20+ NSRL
- Cu 11+ RHIC
- Kr 18+ NSRL
- Xe 27+ NSRL
- Ta 38+ NSRL
- Au 32+ RHIC & NSRL
- U 39+ RHIC

Carbon (and silicon ?) are new beams this fall

Future developments the BNL EBIS program

- Polarized He-3 source
- Brillouin gun tests on Test EBIS
- Brillouin gun / Fe²⁶⁺ for NSRL
- Laser Ion Source for 1+ injection into EBIS

- RhicEBIS and all systems making up the new EBIS preinjector are operating as expected.
- EBIS has delivered a variety of ion beams to both NSRL and RHIC
- EBIS has operated above its design value of 10A electron beam (12A).
- Extracted ion charge with He gas injection reached 85.6% of the electron charge in the trap
- EBIS source *charge* out exceeds the design value, but the % in desired charge state is lower than design. The result is that the *current in the desired charge state is ~ the design value.*
- Several improvements are being implemented to increase the intensity at Booster extraction. (MEBT steering, additional matching quad at Booster, and increased gap of the inflector).
- Ion intensity at electron beams ~10A has been developed meeting the design goal for acceleration of ions such as U39+, Au32+ and Cu11+ for RHIC. Intensity and luminosity goals have been met with the help of bunch merging and increased EBIS duty factor.